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| **a-Si** | Silicium amorphe |
| **CdS** | Sulfure de Cadmium |
| **CdTe** | Tellurure de Cadmium |
| **CGS** | Séléniure de Cuivre et de Gallium |
| **CIGS** | Cuivre-Indium/Gallium-Sélénium |
| **CIS** | Séléniure de Cuivre et d'Indium |
| **IEC** | International Electrotechnical Commission |
| **PVD** | Physical Vapor Deposition |
| **CVD** | Chimicl Vapor Deposition |
| **TCO** | Oxyde Transparent Conducteur |
| **NREL** | National Renevlable Energy Laboratory |
| **BC** | Bande conduction |
| **BV** | Bande valence |
| **DC** | Direct Current |
| **AC** | Alternating Current |
| **RF** | Radio Fréquence |
| **TRIM** | Traspot of Ion in Matter | |
| **SRIM** | Stopping and Range of Ions in Matter | |
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